

# Mutual promotion on the mechanical and tribological properties of the nacre-like self-lubricant film designed for demanding green tribological applications

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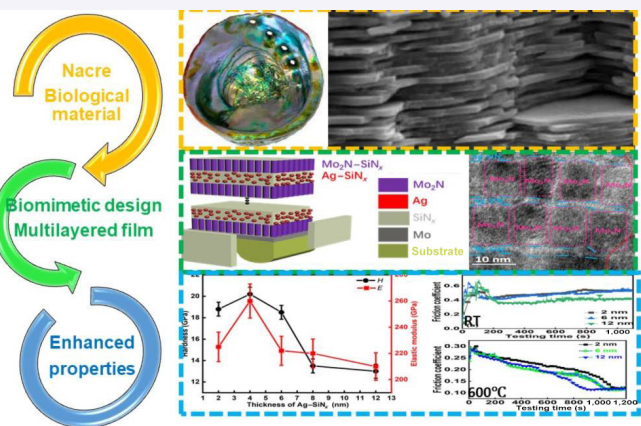
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**ABSTRACT:** The inverse relationship between the tribological and mechanical properties of environmentally friendly self-lubricant films, induced by the addition of soft lubricant agents that can diffuse quickly at elevated temperatures, has hindered the widespread use of these materials in industrial applications. This paper took this challenge to break through the above established relationship by developing novel nacre-like multilayered  $\text{Mo}_2\text{N-SiN}_x/\text{Ag-SiN}_x$  self-lubricant films via a radio frequency (RF) magnetron sputtering system for real applications where harsh conditions at elevated temperatures exist. The multilayered films, deposited by alternating deposition of  $\text{Mo}_2\text{N-SiN}_x$  and  $\text{Ag-SiN}_x$  modulation layers, exhibited three phases of face-centered cubic (fcc)  $\text{Mo}_2\text{N}$ , fcc Ag and  $\text{SiN}_x$ , where  $\text{SiN}_x$  encapsulated the nano-crystalline  $\text{Mo}_2\text{N}$  and Ag phases in each layer to successfully induce a “brick and mortar” nacre-like microstructure (in the area without the coherent structure). The epitaxy growth of the  $\text{Ag-SiN}_x$  layers with thickness below 6 nm on the  $\text{Mo}_2\text{N}$  template resulted in an extraordinary increase in both the hardness and elastic modulus, which was able to prevent severe degradation of the mechanical properties caused by the addition of Ag. The room-temperature anti-friction property could be enhanced by increasing the  $\text{Ag-SiN}_x$  layer thickness due to the excellent lubricant nature of Ag, which acts in synergy with  $\text{Mo}_2\text{N}$ , while the wear rate below  $4 \times 10^{-8} \text{ mm}^3/(\text{N}\cdot\text{mm})$  was due to the high mechanical strength. The tribological properties at 600 °C also benefited from the interlocked multilayered architecture, which allowed an extreme low friction coefficient of  $\sim 0.12$  and a negligible wear rate (WR). This behavior was attributed to the synergism between the lubricant action of Ag and  $\text{Mo}_2\text{N}$  and the tribo-phase transformation from  $\text{Ag}_2\text{Mo}_4\text{O}_{13}$  to  $\text{Ag}_2\text{MoO}_4$ .

**KEYWORDS:** radio frequency (RF) magnetron sputtering system;  $\text{Mo}_2\text{N-SiN}_x/\text{Ag-SiN}_x$  self-lubricant films; interlocked structure; epitaxial growth; lubrication synergism; tribo-phase transformation

## 1 Introduction

Friction and wear are inevitable factors contributing to energy consumption in every industry sector [1]. The development of versatile and environmentally friendly lubricants, with the aim of substituting fossil fuel derivatives, has consistently been seen as the most direct path to fulfilling the demands of a more



environmentally sustainable future and achieving energy conservation goals [2–4]. Friction and wear are predominantly surface-related phenomena. Therefore, modifying the surfaces through the deposition of low-friction films provides a means to address the limitations of liquid lubricants, such as restricted operational temperature ranges, limited load-bearing capacity, highly costly recycling processes, and their unsuitability for use in

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vacuum environments and corrosive media [5]. Over the last decade, potential chemically inert solid lubricant agents with low shear moduli (e.g., Ag and Au) have been widely introduced into hard ceramic-based films to achieve enhanced tribological performance over a wide temperature range [6–12]. Although improved tribological performance can often be attained in composite films by incorporating appropriate amounts of potential lubricant agents, the rapid diffusion of these agents toward the film's surface can lead to premature component failure when exposed to elevated temperatures [13–15]. Furthermore, lubricant agents are often soft phases that can degrade the overall mechanical strength of composite films [16, 17]. However, through advanced film design, it is possible to accelerate the implementation of these films in various industrial applications. Another critical challenge when self-lubricating films are applied in industrial settings is the necessity to simultaneously improve their long-term lubrication capabilities across a wide temperature range while simultaneously maintaining their mechanical properties.

Two main effective approaches have been reported for achieving long-term self-lubrication through controlling the release of lubricant agents: (i) One is the composite configuration, which involves adding a protection phase into the self-lubricant matrix to protect the lubricant agents from oxidation and diffusion to the surface. For example, WC and WS<sub>2</sub> nano-size particles were added to an amorphous diamond-like carbon (DLC) matrix prepared by physical vapor deposition (PVD), and the results confirmed the efficient protection of the DLC to achieve long-term lubrication under humidity testing conditions [18–20]. Amorphous SiN<sub>x</sub> (a-SiN<sub>x</sub>) was also introduced into self-lubricant nitride-based films, such as Mo<sub>2</sub>N–Cu [21], Mo<sub>2</sub>N [22], and TiN–Ag [23], to synthesize a composite film in which a low release of lubricant agents was reported. (ii) A multilayered architecture containing barrier layers [24, 25] whose tribological properties were improved by inserting SiN<sub>x</sub> layers into the main Mo<sub>2</sub>N–Ag film [26]. This enhancement can be attributed to the gradual release of Ag at elevated temperatures [26]. Nevertheless, the obvious interface between adjacent layers easily induces interlayer delamination under the shear force arising during sliding. Moreover, the difference in chemical/physical compatibility degrades the cohesion of the films.

On the other hand, it seems extremely difficult to achieve the goal of simultaneously maintaining excellent self-lubrication with a high level of mechanical strength. In fact, excellent self-lubricant properties require a suitable content of a soft potential lubricant agent. For example, more than 15 at% soft metal (SMe) is mandatory for achieving satisfactory elevated-temperature lubricant properties of transition metal nitride (TMN)–SMe films [27]. Magnetron-sputtered TiN–Ag composite films were reported to exhibit the best lubricating performance from room temperature (RT) up to 500 °C when the Ag/(Ag+2Ti) ratio was 45 at%, which leads, in this case, to a hardness of only 8 GPa [28]. Ag and Cu were added into Ti–Al–N hard films deposited by PVD, and the results confirmed that 20 at% of Ag and Cu enhanced the anti-frictional properties, resulting in a friction coefficient (CoF) of ~0.1 at the cost of decreasing the hardness down to ~7 GPa [29]. Similar results have also been reported in other systems of TaN–Ag [30], VN–Ag [31, 32], and NbN–Ag [33] films.

Achieving a balance between long-term lubrication and mechanical properties of self-lubricating films remains a challenge in the field of solid lubrication nowadays. It is essential to prevent both excessive diffusion of lubricant agents to the surface and the

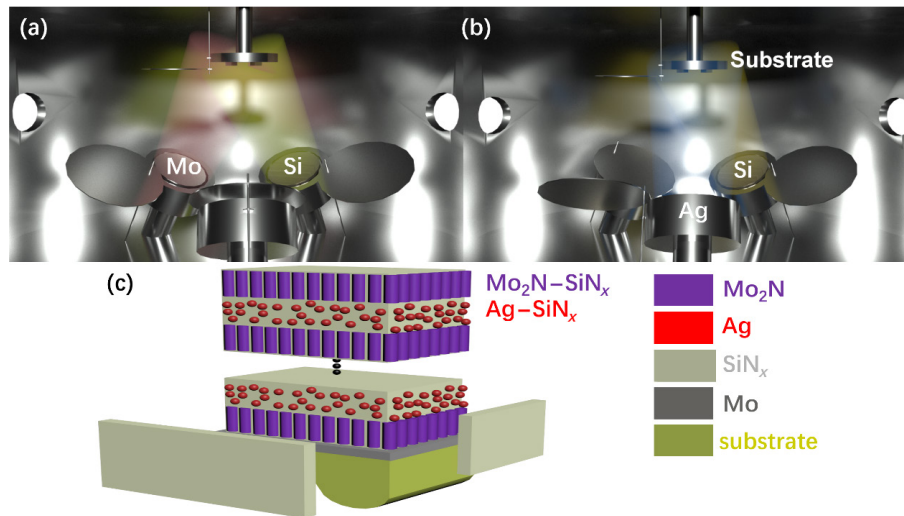
reduction of the overall mechanical properties due to the addition of soft components.

The design and fabrication of biomimetic materials inspired from nature has been widely reported as an efficient method to remarkably enhance their properties [34] because of the amazing well-organized biological microstructure resulting from millions of years of evolution [35]. One of the striking examples of these materials is the mother-of-pearl, also known as nacre [36]. Its fully evolved microstructure of ceramic tablets densely packed and bonded together by a thin layer of biopolymer [36], resulted in mechanical properties, including elastic modulus, yield strength and toughness, much better than those of each individual layer of nacre [37]. Some biomimetic materials were designed on the basis of the unique microstructure of nacre, with a “brick and mortar” characteristic [38]. In this study, a novel interlocked structure design inspired by the “brick and mortar” microstructure of nacre is applied to develop Mo<sub>2</sub>N–SiN<sub>x</sub>/Ag–SiN<sub>x</sub> multilayered self-lubricant films. This approach enables the development of environmentally friendly solid lubricants by simultaneously enhancing both their lubricating and mechanical properties: (i) The nacre-like structure, by introducing SiN<sub>x</sub> to encapsulate the lubricant agent of either Mo<sub>2</sub>N or Ag, will protect Mo<sub>2</sub>N against oxidation and Ag from anti-diffusion, respectively, at elevated temperatures; (ii) the suitable content of the lubricant agents of Mo<sub>2</sub>N and Ag can be easily deposited into the separated modulation layered structure to maintain excellent self-lubricant properties at a wide range of temperatures; (iii) the thickness of Mo<sub>2</sub>N–SiN<sub>x</sub> and Ag–SiN<sub>x</sub> layers will be changed to induce coherency between the phases to compensate for the influence of the low mechanical strength of Ag. Therefore, Mo<sub>2</sub>N–SiN<sub>x</sub>/Ag–SiN<sub>x</sub> multilayered films were deposited using radio frequency (RF) magnetron sputtering with the thickness of Mo<sub>2</sub>N–SiN<sub>x</sub> fixed at 15 nm and the thickness of Ag–SiN<sub>x</sub> varying from 2 to 12 nm. Then, the influence of the interlocked structure of the film on the mechanical and tribological properties is discussed.

## 2 Experimental

### 2.1 Deposition process

A series of Mo<sub>2</sub>N–SiN<sub>x</sub>/Ag–SiN<sub>x</sub> multilayered films were prepared using high-purity (99.9%) Mo, Si, and Ag targets (Deyang ONA new materials Co., Ltd., China) by RF magnetron sputtering (Fig. 1). Polished high-speed steel W18Cr4V (W18) and Si(100) wafers (Deyang ONA new materials Co., Ltd., China) were used as substrates, and their roughnesses were approximately 0.4 and 50 nm, respectively. Before deposition, the substrates were ultrasonically cleaned in alcohol for 15 min and then in acetone for 15 min. High-speed steel substrates were used for tribo-tests at room and elevated temperatures, whilst Si substrates were used for microstructural studies and measurements of mechanical properties. The distance between the targets and substrates was set to 80 mm. Before deposition, the chamber was pumped down below 6.0×10<sup>-4</sup> Pa. First, a Mo adhesion layer with a thickness of ~150 nm was deposited with an Ar flow rate of 10 standard cubic centimeters per minute (sccm) to improve the adhesion between the film and the substrate. Following this, the multi-layer structure was created by alternately opening the shutters for the Mo and Ag targets while keeping the Si target shutter open. In all deposition processes, the films were produced by applying power levels of 250, 80, and 80 W to the Mo, Si, and Ag targets, respectively, under a deposition pressure of 0.3 Pa and a gas mixture of Ar/N<sub>2</sub> at a ratio of 10/3. By adjusting the opening time of the shutter on the sputtering Mo and Ag targets, various multilayered films were



**Fig. 1** 3D schematic image of the deposition of multilayered films: (a) deposition of  $\text{Mo}_2\text{N-SiN}_x$  layers, (b) deposition of  $\text{Ag-SiN}_x$  layers, and (c) 3D schematic image of multilayered film.

produced. These films maintained a consistent  $\text{Mo}_2\text{N-SiN}_x$  layer thickness of 15 nm, while the  $\text{Ag-SiN}_x$  layer thickness was varied from 2 to 12 nm. No bias or substrate heating was applied during the deposition. The total thickness designed for all the multilayered films was approximately 2.0  $\mu\text{m}$ .

## 2.2 Structural characterization

The crystal structure of  $\text{Mo}_2\text{N-SiN}_x/\text{Ag-SiN}_x$  films was determined by an X-ray diffractometer (XRD; Shimadzu-6000, Shimadzu, Japan) with  $\text{Cu K}\alpha$  radiation at a passing energy of 160 eV and  $2\theta$  in the range of  $20^\circ$ – $80^\circ$  with a step of  $0.4^\circ$ . The samples for TEM analysis were prepared using an FEI Helios G4CX dual-beam system (Thermo Fisher Scientific, USA) with a  $\text{Ga}^+$  ion source after a protective W mask was deposited. The acceleration voltage for focused ion beam (FIB) milling was 30 kV for rough operations, followed by 5 and 2 kV for final polishing. The FIB lamellae were examined via an FEI Titan Themis<sup>3</sup> S/ transmission electron microscopy (TEM) microscope (Thermo Fisher Scientific, USA) operating at 300 kV. Using an energy-dispersive X-ray (EDS) Super-XG1 detection system with 4 windowless silicon drift detectors (SDDs), elemental mapping of the samples was performed.

## 2.3 Mechanical and tribological characterizations

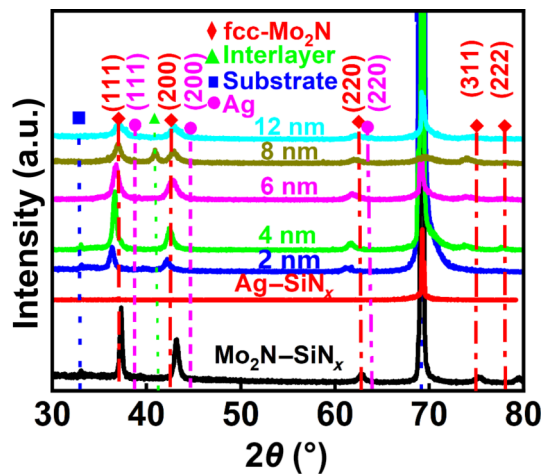
The hardness ( $H$ ) and elastic modulus ( $E$ ) were measured by a nano-indenter (CPX+NHT2+MST, Anton Paar, Switzerland), with a constant loading force of 3 mN and holding time of 10 s. To ensure the accuracy of the results, 15 measurements were conducted in 2 different zones of the samples. The RT and 600  $^\circ\text{C}$  wear tests were conducted in a pin-on-disc tester (UMT-2, CETR, USA) using alumina balls (diameter of 9.4 mm) as counterparts in open air. The rotation speed was 50 r/min, and the sliding time was 20 min; the applied load was 3 N, and the radius of the wear track was 4 mm. During RT wear tests, the relative humidity was  $\sim 30\%$ . After the wear tests, the average friction coefficient of the films was taken from the steady-state zone of their corresponding friction curves. The two-dimensional (2D) profiles of the wear tracks were measured using a three-dimensional (3D) profiler (Dektak-XT, Bruker, Germany), and the wear rates (WRs) of the films were obtained using Archard's law. SEM observations and a Raman spectrometer (inVia, Renishaw, UK), were used to study wear tracks.

## 3 Results and discussion

### 3.1 Micro(structure)

Figure 2 shows the XRD patterns of the reference monolayered  $\text{Mo}_2\text{N-SiN}_x$  and  $\text{Ag-SiN}_x$  films and multilayered  $\text{Mo}_2\text{N-SiN}_x/\text{Ag-SiN}_x$  films. The diffraction pattern of the  $\text{Mo}_2\text{N-SiN}_x$  monolayer film reveals a fcc structure, assigned to fcc- $\text{Mo}_2\text{N}$  (JCPDF No. 15-2366) phase with the corresponding (111), (200), (220), (311), and (222) diffraction peaks. Moreover, another diffraction peak at  $2\theta$  of  $\sim 69^\circ$  was detected from the Si substrate. Probably, a dual phase of fcc- $\text{Mo}_2\text{N}$  and amorphous  $\text{SiN}_x$  can co-exist in the  $\text{Mo}_2\text{N-SiN}_x$  monolayer film, in a capsule-like structural characteristic with the  $\text{Mo}_2\text{N}$  grains encapsulated by an amorphous  $\text{SiN}_x$  phase, as presented in previous papers [21, 39]. In the case of  $\text{Ag-SiN}_x$  monolayer film, no obvious diffraction peaks can be observed except for those from the Si substrate due to the relatively low intensity of the Ag diffraction peaks (the diffraction peaks of Ag were observed in our previous paper [12]). Based on our previous high-resolution TEM (HRTEM) results [12], this monolayer film can exhibit a dual phase of fcc-Ag nanoparticles embedded in an amorphous  $\text{SiN}_x$  matrix. Therefore, the Ag metallic phase present in the form of small clusters can explain the absence of XRD peaks. The XRD patterns of all multilayered films, regardless of the thickness of the  $\text{Ag-SiN}_x$  layer, exhibit two different series of diffraction peaks, which are assigned to the fcc- $\text{Mo}_2\text{N}$  and Si substrates. The diffraction peaks are located at lower angles than those from the monolayered  $\text{Mo}_2\text{N-SiN}_x$  film. This shift is related to the epitaxial deposition of  $\text{Ag-SiN}_x$  layers on the  $\text{Mo}_2\text{N}$  template (see the HRTEM section): The epitaxy structure easily induces compressive stresses in the  $\text{Mo}_2\text{N}$  phase due to the lower lattice parameter of Ag in relation to that of  $\text{Mo}_2\text{N}$ , resulting in a dilatation in the perpendicular directions and, thereby, the diffraction peaks of  $\text{Mo}_2\text{N}$  shifting to lower angles. However, the compressive stress could be released by further increasing the number of  $\text{Ag-SiN}_x$  layers above 6 nm, since epitaxy should not be possible throughout the entire  $\text{Ag-SiN}_x$  layer.

The state of the chemical bonds in the monolayered films has been discussed in our previously published works [26, 39, 40], and the results are in good agreement with the evolution of the XRD patterns presented in Fig. 2. The dual-phases of both fcc- $\text{Mo}_2\text{N}$  and amorphous  $\text{SiN}_x$  co-exist in the  $\text{Mo}_2\text{N-SiN}_x$  monolayer film since both the Mo–N bonds [21, 41] (fcc- $\text{Mo}_2\text{N}$ ) and Si–N bonds



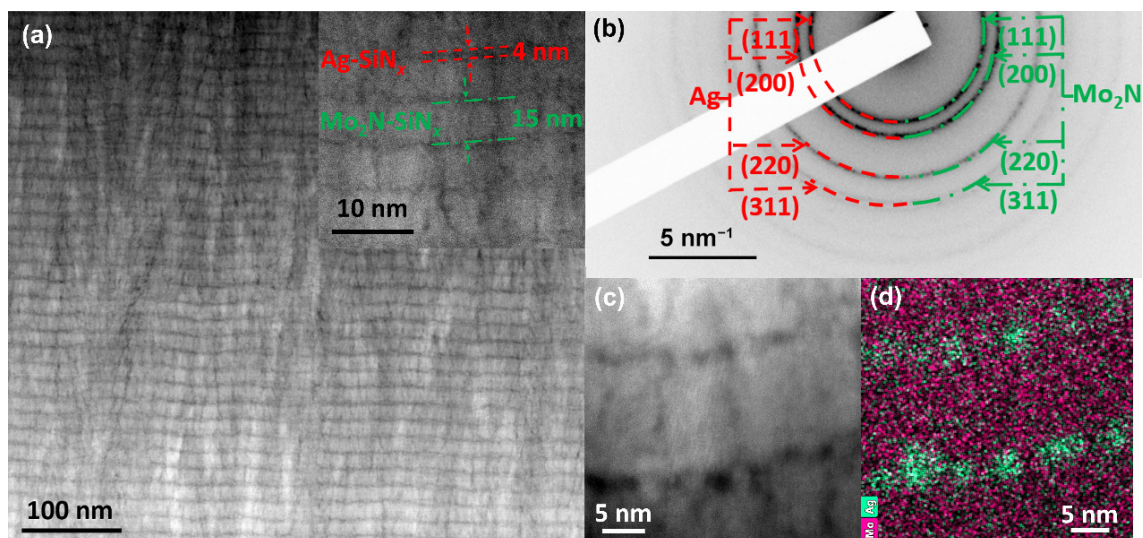
**Fig. 2** XRD diffraction patterns of reference  $\text{Mo}_2\text{N-SiN}_x$  and  $\text{Ag-SiN}_x$  monolayer films, and  $\text{Mo}_2\text{N-SiN}_x/\text{Ag-SiN}_x$  multilayered films with varied thickness of  $\text{Ag-SiN}_x$  layers.

[42–44] (amorphous  $\text{SiN}_x$ ) can be detected in the X-ray photoelectron spectroscopy (XPS) spectrum. The  $\text{Ag-Ag}$  bonds [12], referred to as the nanoparticles of Ag, and the  $\text{Si-N}$  bonds [12] in amorphous  $\text{SiN}_x$  appear in the XPS spectrum of the  $\text{Ag-SiN}_x$  monolayer film. This also confirms the presence of embedded Ag nanoparticles in the amorphous matrix.

To obtain detailed information about the structure of the multilayer films and their interfacial characteristics, TEM was used, as shown in Fig. 3. The cross-sectional high-angle annular dark-field (HAADF) image of a multilayer film is shown in Fig. 3(a), and an obvious contrast between  $\text{Mo}_2\text{N-SiN}_x$  and  $\text{Ag-SiN}_x$  layers can be seen. The bright and dark layers in this figure correspond to  $\text{Mo}_2\text{N-SiN}_x$  and  $\text{Ag-SiN}_x$ , respectively. The thickness of each layer aligns well with the intended design: approximately 15 nm for  $\text{Mo}_2\text{N-SiN}_x$  and 4 nm for  $\text{Ag-SiN}_x$ . The selected area electron diffraction (SAED) image acquired from the multilayered specimen in Fig. 3(a) is shown in Fig. 3(b), with the ring patterns corresponding to the (111), (200), (220), and (311) reflections characteristics of the fcc phase. In accordance with the XRD analysis shown in Fig. 2, a significant contribution to the electron diffraction patterns of the Ag phase is not expected; moreover it can be hard to separate these signals due to the very

close lattice parameters of  $\text{Mo}_2\text{N}$  and Ag. The high-resolution HAADF image and its corresponding Ag and Mo EDS element maps are shown in Figs. 3(c) and 3(d). The Ag in the  $\text{Ag-SiN}_x$  layer is not distributed homogeneously and forms only clusters with a diameter of  $\sim 4$  nm. This suggests that the Ag particles are embedded into the  $\text{SiN}_x$  matrix. These results are similar to those reported for the  $\text{Ag-SiN}_x$  monolayer system deposited with different silver contents [12].

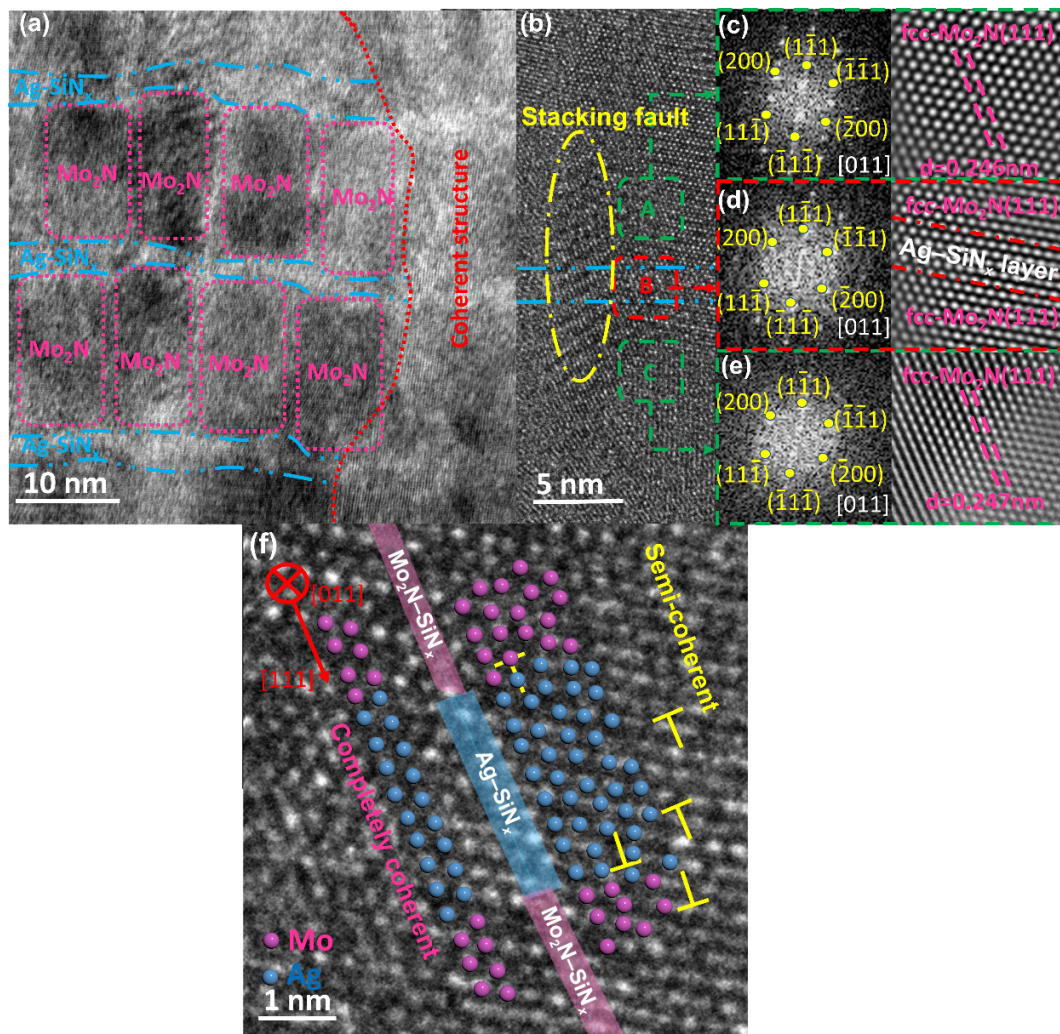
HRTEM was used to further investigate the cross-sectional microstructure characteristics of the film with 4 nm  $\text{SiN}_x$  layer, and the results are shown in Fig. 4. Figure 4(a) shows an obvious multilayered architecture consisting of bright  $\text{Ag-SiN}_x$  and dark  $\text{Mo}_2\text{N-SiN}_x$  layers. The amorphous and crystal phases co-exist in the  $\text{Mo}_2\text{N-SiN}_x$  layer, and the crystal phase refers to fcc- $\text{Mo}_2\text{N}$  based on its lattice fringe with a spacing of 0.246 nm (fcc- $\text{Mo}_2\text{N}(111)$ , JCPDF No. 15-2366). The coherency characteristics could be detected in the right half of this figure, with obvious lattice fringes throughout several layers of  $\text{Ag-SiN}_x$  and  $\text{Mo}_2\text{N-SiN}_x$ . Either Ag or  $\text{SiN}_x$  in the  $\text{Ag-SiN}_x$  layers contributes to the epitaxy structure, since the discontinuous Ag nanoparticles are too small (Fig. 3(d)) to fully contribute to the epitaxy area in Fig. 4(a). The  $\text{Ag-SiN}_x$  layers without coherency with the  $\text{Mo}_2\text{N-SiN}_x$  template were observed to be in a mixed crystalline and amorphous state (Fig. 4(a)). The corresponding monolayer film also exhibits a dual phase of fcc-Ag and amorphous  $\text{SiN}_x$  based on our previous results [12]. Each modulation layer, either  $\text{Ag-SiN}_x$  or  $\text{Mo}_2\text{N-SiN}_x$ , consists of amorphous and crystalline phases, where the  $\text{Mo}_2\text{N}$  or Ag crystallites are surrounded by an amorphous tissue in the region without the coherency characteristic. Moreover, it is hard to observe the interface characteristics in the amorphous region of the  $\text{Mo}_2\text{N-SiN}_x$  layer with the  $\text{Ag-SiN}_x$  one. High density of stacking faults (SFs) are also detected in each layer, the region marked with a yellow line. The fast Fourier transforms (FFTs) in Figs. 4(c)–4(e), all with the [011] zone axis (z.a.), derived from the center of  $\text{Mo}_2\text{N-SiN}_x$  (area A),  $\text{Mo}_2\text{N-SiN}_x+\text{Ag-SiN}_x$  (area B), and  $\text{Mo}_2\text{N-SiN}_x$  layers (area C), exhibit only one set of spots corresponding to the fcc phase. This result also confirms the existence of coherent interface regions between layers and the epitaxial growth of fcc-Ag on the fcc- $\text{Mo}_2\text{N}$  template. Figure 4(f) shows the HRTEM bright field (BF) image of the multilayered film from the interface region, which is aligned along the [011] zone axis. The dual interface



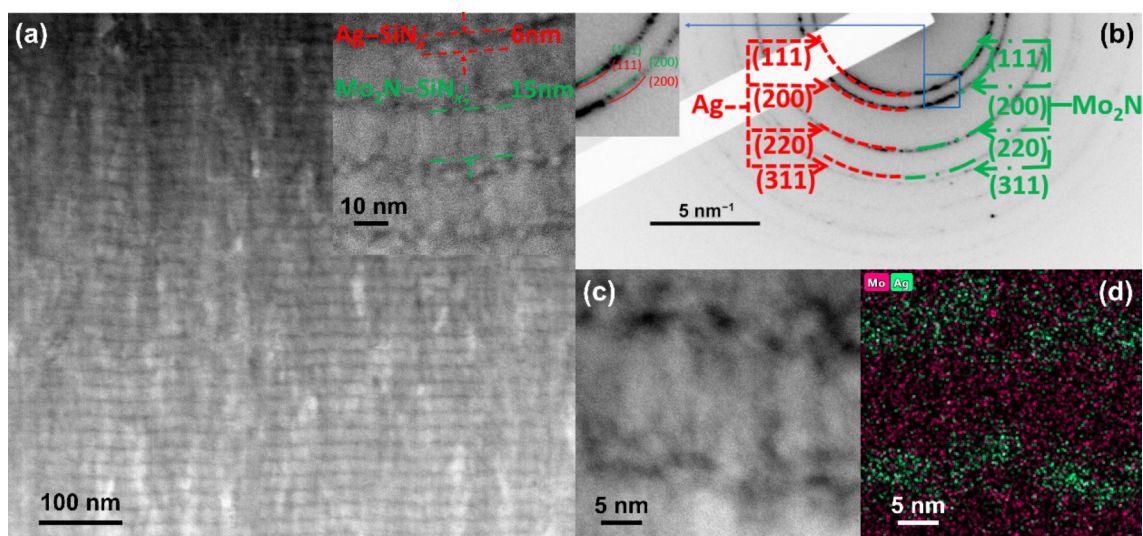
**Fig. 3** (a) Cross-sectional HAADF image of  $\text{Mo}_2\text{N-SiN}_x/\text{Ag-SiN}_x$  multilayer film with  $\text{SiN}_x$  layer thickness of 4 nm, (b) corresponding SEAD pattern, (c) high-magnification HAADF image, and (d) its corresponding Ag and Mo elements mapping.

characteristics, including both completely coherent and semi-coherent characteristics, could be detected, and obvious dislocations appear in the semi-coherent regions.

The TEM results of the cross-sectional multilayer film with a  $\text{SiN}_x$  layer thickness of 6 nm are shown in Fig. 5. Figure 5(a) shows the HAADF dark-field (DF) image of the film where the



**Fig. 4** (a) BF HRTEM cross-sectional image of  $\text{Mo}_2\text{N-SiN}_x/\text{Ag-SiN}_x$  multilayer film with  $\text{SiN}_x$  layer thickness of 4 nm; (b) enlarged BF HRTEM image of film and its corresponding FFT pattern in areas of (c) A, (d) B, and (e) C in (b); (f) BF HRTEM image from interface area of film.



**Fig. 5** (a) HAADF DF image of cross-sectional  $\text{Mo}_2\text{N-SiN}_x/\text{Ag-SiN}_x$  multilayer film with  $\text{SiN}_x$  layer thickness of 6 nm, (b) its corresponding SEAD pattern, (c) enlarged HAADF DF image, and (d) its corresponding Ag and Mo elements mapping.

interface between adjacent layers is still detected. The thickness of the  $\text{Mo}_2\text{N-SiN}_x$  layer in the film is  $\sim 15$  nm, but the thickness of the  $\text{SiN}_x$  layer increases to  $\sim 6$  nm (inset of Fig. 5(a)). Discontinuous white particles (Ag due to its high atomic number) can be detected in the inset of Fig. 5(a). Only one set of diffraction rings appear in Fig. 5(b), corresponding to the (111), (200), (220), and (311) reflections characteristic of the fcc phase. The enlarged HAADF DF cross-sectional image of the multilayer film (Fig. 5(c)) further confirms the presence of discontinuous Ag particles in the Ag-SiN<sub>x</sub> layer, which is related to the poor wettability of metal Ag on the surface of the ceramic-based template, either  $\text{Mo}_2\text{N}$  or  $\text{SiN}_x$ , and its low solubility in the  $\text{SiN}_x$  matrix [12]. The corresponding Ag and Mo element mapping data are shown in Fig. 5(d). The results confirm the multilayered architecture of the film with Ag nanoparticles of the diameter in the range of 2–5 nm.

HRTEM BF images for the cross-section of the multilayered film at the 6 nm  $\text{SiN}_x$  layer are depicted in Fig. 6 to further investigate the phase structure and interface characteristics. The light region in Fig. 6(a) refers to  $\text{SiN}_x$ , whereas the grey and dark regions correspond to  $\text{Mo}_2\text{N}$  and Ag, respectively, due to their different atomic numbers. Nanoparticles of Ag are uniformly distributed in the Ag-SiN<sub>x</sub> layers, and the characteristic nanocapsule arrangement of the crystalline  $\text{Mo}_2\text{N}$  grains encapsulated by amorphous  $\text{SiN}_x$  could be detected in the  $\text{Mo}_2\text{N-SiN}_x$  layers in the region without the coherency characteristic. An interlocked structure is then also formed, similar to a multilayered film with a 4 nm Ag-SiN<sub>x</sub> layer (Fig. 4). A higher-magnification HRTEM image, shown in Fig. 6(b), also confirms that the average diameter of the Ag nanoparticles is in the range of 2–5 nm inside the Ag-SiN<sub>x</sub> layers. The average width of the crystalline  $\text{Mo}_2\text{N}$  grains and the thickness of the encapsulated amorphous  $\text{SiN}_x$  in the  $\text{Mo}_2\text{N-SiN}_x$  layers are  $\sim 10$  and  $\sim 3$  nm, respectively. The FFT pattern from region A in Fig. 6(b) is shown in Fig. 6(c), and two series of spots referring to an fcc structure can be detected. However, its corresponding inverse fast fourier transform (IFFT) image, as shown in Fig. 6(d), exhibits the same lattice arrangement with a plane spacing of  $\sim 0.247$  nm, which is close to that of fcc- $\text{Mo}_2\text{N}(111)$  (JCPDF No. 15-2366). Thus, the coherency structure still exists in the multilayer film but cannot cross throughout several modulation layers, such as the one with an Ag-SiN<sub>x</sub> layer of 4 nm.

The interfaces of the multilayered films significantly depend on the critical thickness of the Ag-SiN<sub>x</sub> layers, based on the above HRTEM results, and two possibilities of forming the coherency structure between the  $\text{Mo}_2\text{N-SiN}_x$  layer and its adjacent Ag-SiN<sub>x</sub> layers: (i) The fcc-Ag particles epitaxially grow from the fcc- $\text{Mo}_2\text{N}$

template, and (ii) the  $\text{SiN}_x$  layer grows epitaxially and forms coherent interfaces with the template. The width of the coherency area is larger than the size of Ag nanoparticles in the Ag-SiN<sub>x</sub> layers, based on the results shown in Fig. 4, and consequently, both Ag and  $\text{SiN}_x$  contribute to the formation of the coherency structure. The critical thickness of each phase epitaxy with the template can be evaluated as follows.

As for the coherency structure between  $\text{SiN}_x$  and  $\text{Mo}_2\text{N}$ , the recrystallization of  $\text{SiN}_x$  layer with a thickness of several nanometers, resulting from nitride-based templates such as TiN [45, 46], AlN [47], and ZrN [48, 49], could be accomplished via the multilayered architecture to decrease the total Gibbs free energy. Therefore, the total energy ( $E_T$ ) per unit area of fcc- $\text{SiN}_x$  ( $E_T^{w-\text{Si}_3\text{N}_4}$ ) should be lower than that of a- $\text{SiN}_x$  ( $E_T^{a-\text{Si}_3\text{N}_4}$ ):  $E_T^{w-\text{Si}_3\text{N}_4} < E_T^{a-\text{Si}_3\text{N}_4}$ . If the  $\text{SiN}_x$  layer epitaxially grows with the  $\text{Mo}_2\text{N}$  template to form fcc- $\text{SiN}_x$ , the  $E_T^{w-\text{Si}_3\text{N}_4}$  and  $E_T^{a-\text{Si}_3\text{N}_4}$  can be calculated based on Eqs. (1) and (2):

$$E_T^{w-\text{Si}_3\text{N}_4} = 2E_1^{w-\text{Si}_3\text{N}_4/c-\text{AlN}} + E_b^{w-\text{Si}_3\text{N}_4} t + E_s t \quad (1)$$

$$E_T^{a-\text{Si}_3\text{N}_4} = 2E_1^{a-\text{Si}_3\text{N}_4/c-\text{AlN}} + E_b^{a-\text{Si}_3\text{N}_4} t \quad (2)$$

where  $E_1$ ,  $E_b$ ,  $E_s$ , and  $t$  are the interface energy, volumetric energy, strain energy, and thickness of the  $\text{SiN}_x$  layer, respectively.

The critical thickness ( $t_c$ ) of the  $\text{SiN}_x$  layer epitaxially growing with the template fcc- $\text{Mo}_2\text{N}$  could be calculated based on Eqs. (3) and (4):

$$t_c = \frac{2(E_1^{a-\text{Si}_3\text{N}_4/c-\text{AlN}} - E_1^{w-\text{Si}_3\text{N}_4/c-\text{AlN}})}{E_b^{w-\text{Si}_3\text{N}_4} - E_b^{a-\text{Si}_3\text{N}_4} + \frac{1}{2} Y \epsilon^2} \quad (3)$$

$$E_s = \frac{1}{2} Y \epsilon^2 \quad (4)$$

where  $Y$  and  $\epsilon$  are the modulus and strain in the interlayer of  $\text{SiN}_x$ , respectively.

The above equations can be derived as follows, since the interface energy is very low because the coherency structure reduces the number of interfaces.

$$t_c = \frac{4E_1^{a-\text{Si}_3\text{N}_4/\text{fcc-Mo}_2\text{N}}}{Y \epsilon^2} \quad (5)$$

$$\epsilon_A = \frac{f}{1 + \frac{G_A t_A}{G_B t_B}} \quad (6)$$

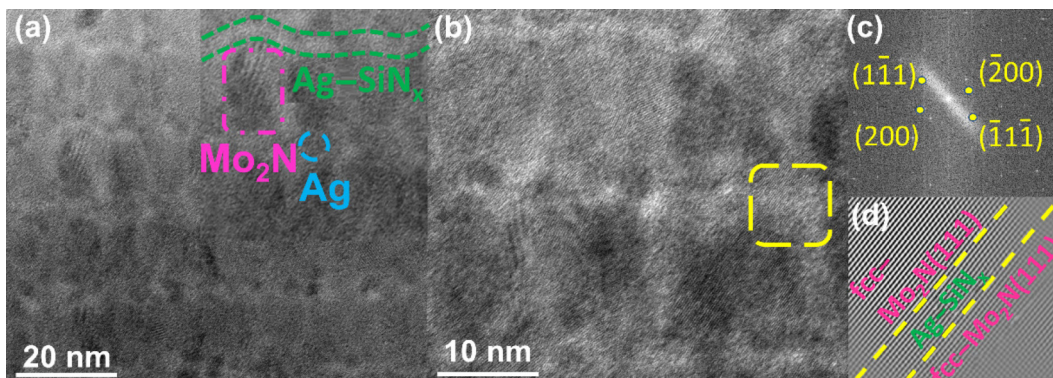


Fig. 6 (a, b) HRTEM BF image of cross-sectional  $\text{Mo}_2\text{N-SiN}_x/\text{Ag-SiN}_x$  multilayer film with  $\text{SiN}_x$  layer thickness of 6 nm; (c) FFT and (d) IFFT image from the coherency region (region A).

$$f = \frac{a_f - a_s}{a_s} \quad (7)$$

where  $G$  is the shear modulus;  $t$  is the thickness of the film; subscript A represents  $\text{Mo}_2\text{N-SiN}_x$  layer; subscript B represents  $\text{Ag-SiN}_x$  layer;  $f$  is the mismatch of the modulation layers;  $a_f$  is the lattice constant of  $\text{fcc-Mo}_2\text{N}$ ;  $a_s$  is the lattice constant of the one epitaxial growth with  $\text{fcc-Mo}_2\text{N}$ .

The critical thickness of  $\text{SiN}_x$  epitaxially grown with the  $\text{Mo}_2\text{N}$  template is 0.9 nm based on the above equations. This calculated value is in good agreement with the experimental result from the  $\text{SiN}_x/\text{Mo}_2\text{N}$  multilayer film exhibiting a coherency structure with a  $\text{SiN}_x$  layer thickness of 0.8 nm [22]. However, the multilayer film in this study for the  $< 6$  nm  $\text{Ag-SiN}_x$  layer still has a coherent structure; thus,  $\text{fcc-Ag}$  could be considered the main factor because of the low lattice mismatch between  $\text{Ag}(111)$  and  $\text{Mo}_2\text{N}(111)$ . The critical size of  $\text{Ag}$  nanoparticles epitaxially growing with the nitride-based template was also proved around 4 nm in our previous Ref. [27].

Based on above results, the  $\text{Mo}_2\text{N-SiN}_x/\text{Ag-SiN}_x$  multilayer film formed by alternating deposition of  $\text{Mo}_2\text{N-SiN}_x$  and  $\text{Ag-SiN}_x$  layers exhibits three phases of  $\text{fcc-Mo}_2\text{N}$ ,  $\text{fcc-Ag}$ , and  $\text{SiN}_x$  ( $\text{SiN}_x$  exhibits an amorphous state in the region without a coherency structure but could be crystalline in the coherency zone), regardless of the  $\text{Ag-SiN}_x$  layer thickness. This nano-interlocked structure characteristic of multilayer films is formed by (i) the embedding of  $\text{Ag}$  nanoparticles into the  $\text{SiN}_x$  matrix in the  $\text{Ag-SiN}_x$  layer and (ii) the encapsulation of  $\text{Mo}_2\text{N}$  by a  $\text{SiN}_x$  shell in the  $\text{Mo}_2\text{N-SiN}_x$  layer. The coherency structure could be detected in the multilayer film at the  $\leq 6$  nm  $\text{Ag-SiN}_x$  layer, and the largest region of the coherency structure, crossing several modulation layers, could still be detected for the multilayer film at the 6 nm  $\text{Ag-SiN}_x$  layer.

### 3.2 Mechanical and tribological properties

The hardness and elastic modulus of the multilayer films as a function of the  $\text{Ag-SiN}_x$  layer thickness, as well as the corresponding monolayer films of  $\text{Mo}_2\text{N-SiN}_x$  and  $\text{Ag-SiN}_x$ , are shown in Fig. 7. The hardness and elastic modulus calculated based on rule-of-mixture (ROM) are also shown in Fig. 7 as a reference to confirm the extraordinary increase in both the hardness and elastic modulus induced by the nano-multilayered architecture. The measured hardness values of the  $\text{Mo}_2\text{N-SiN}_x$  and  $\text{Ag-SiN}_x$  monolayer films are  $\sim 17.2$  and  $\sim 7.5$  GPa, respectively. The ROM hardness of the multilayer film decreases gradually with the increase of  $\text{Ag-SiN}_x$  layer thickness. However, the multilayered architecture by alternating the  $\text{Mo}_2\text{N-SiN}_x$  (15 nm) and  $\text{Ag-SiN}_x$  ( $\leq 6$  nm) nano-sized layers could enhance

the hardness, and its tested value increases from  $\sim 18.5$  GPa for the film with the  $\text{Ag-SiN}_x$  layer thickness of 2 nm to  $\sim 20.6$  GPa for the film of the  $\text{Ag-SiN}_x$  layer thickness of 4 nm. The hardness of the multilayered film decreases gradually from  $\sim 18.3$  GPa for the film with the 6 nm  $\text{Ag-SiN}_x$  layer to  $\sim 14.3$  GPa for the film with the 8 nm  $\text{Ag-SiN}_x$  layer, which is very close to the ROM. With a further increase in thickness, the hardness value slightly decreases, which is in good agreement with the ROM value. The coherent interface could not cross from one to the other  $\text{Mo}_2\text{N-SiN}_x$  layers, although it still exists in some areas of the  $\text{Ag-SiN}_x$  layer with the adjacent  $\text{Mo}_2\text{N}$  template. This coherency is lost inside the  $\text{Ag-SiN}_x$  layer because of the high  $\text{Ag-SiN}_x$  layer thickness ( $\geq 8$  nm) and, consequently, relaxing the lattice to less distortion, as well as less hardness, approaching the one from ROM.

The special mechanical characteristic of super-hardness, with an extreme hardness value of above 70 GPa or higher than that of diamond, which occurs for a modulation period of less than 10 nm by a nano-multilayered/composite architecture, has been reported for many novel nano-sized materials [50]. The multiple phases in the  $\text{Mo}_2\text{N-SiN}_x/\text{Ag-SiN}_x$  multilayer film result in a remarkable increase in hardness due to the influence of multiple factors, such as the following.

(i) The coherency strain: The completely or semi-coherent interface of the multilayered film with the  $\text{Ag-SiN}_x$  layer thickness below 6 nm (based on the TEM results) could not fully release the coherency stresses in the film and, hereby, inhibit the partial dislocation motion based on the coherent strain principle, ultimately increasing the hardness of the multilayered films [51].

(ii) Different values of the elastic modulus of each modulation layer. The dislocation energy per unit length of each layer significantly depends on its shear modulus and, consequently, avoids dislocations moving across the interface between the modulation layers to maintain a state of low energy [52]. Thus, it induces a mirror-like stress, referred to as an alternating stress field, such that an additional shear stress with a value at least above  $G/100$  ( $G$  is the shear modulus of the layer with a lower modulus) is needed for the dislocation to overcome [53].

(iii) The region of high-density SFs existing in the multilayered film at the 4 nm  $\text{Ag-SiN}_x$  layer also results in a hardness enhancement since the movement of the dislocations across the interface could be inhibited by the SFs [54, 55]. A classic equation was reported to estimate the resistance capacity ( $\tau$ ) of the SF to the partial dislocation as Eq. (8) [56]:

$$\tau = \frac{\mu b^2 (2 + \nu)}{8\pi (1 - \nu) w} \quad (8)$$

where  $\mu$  is the shear modulus;  $b$  is the Burgers vector;  $\nu$  is the

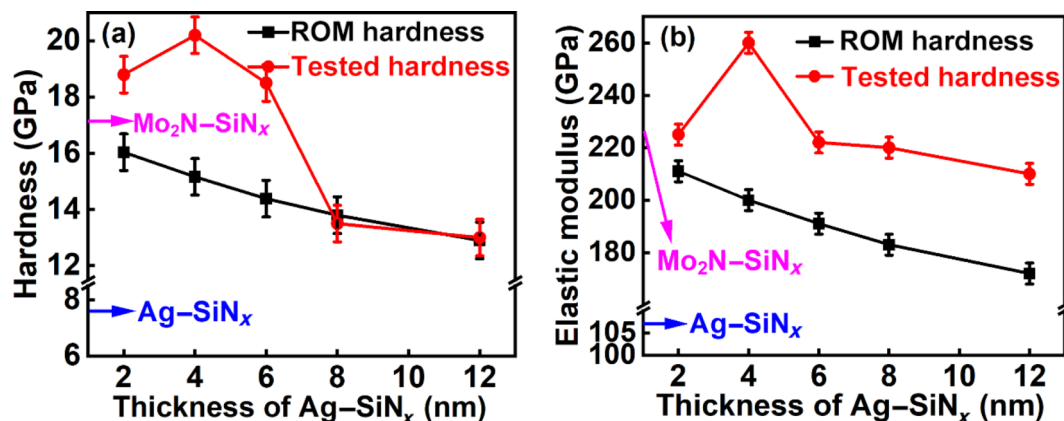


Fig. 7 (a) Hardness and (b) elastic modulus of  $\text{Mo}_2\text{N-SiN}_x/\text{Ag-SiN}_x$  multilayer film as a function of  $\text{SiN}_x$  layer thickness.

Poisson's ratio;  $w$  is the SF width. Therefore, the value of  $\tau$  calculated using the data in Fig. 4 is  $\sim 1.5$  GPa, thereby contributing to the hardness enhancement.

The elastic moduli of the monolithic  $\text{Mo}_2\text{N-SiN}_x$  and  $\text{Ag-SiN}_x$  films are  $\sim 225$  and  $\sim 108$  GPa, respectively, as depicted in Fig. 7(b), and the ROM of the multilayered film gradually decreases with the increase of the  $\text{Ag-SiN}_x$  layer thickness. However, the elastic moduli of all the multilayered films tested, regardless of the  $\text{Ag-SiN}_x$  layer thickness, are greater than the ROM. Moreover, it initially increases and then decreases with the increase of the  $\text{Ag-SiN}_x$  layer thickness after reaching a maximum value of  $\sim 260$  GPa at the 4 nm  $\text{Ag-SiN}_x$  layer.

The remarkable increase in the elastic modulus for the multilayer films in relation to the expected values predicted by a mixture law can be explained by the existence of coherency from both Ag and  $\text{SiN}_x$  phases. An increase in the crystallinity is, then, expected with the consequent increase in the elastic modulus. For the 4 nm  $\text{Ag-SiN}_x$  layer, the coherency through the  $\text{Ag-SiN}_x$  layer is maximized, which results in the peak value shown in Fig. 7(b).

Figure 8 shows representative friction curves and average friction coefficients (CoFs) at RT. A running-in stage, regardless of the thickness of  $\text{SiN}_x$  layer, could be detected in the friction curves. At the beginning of the test, in the running-in, the friction coefficient gradually increases, reaching a local maximum value, and then decreases until it reaches a stable value. The duration of the running-in stage is extended as the  $\text{Ag-SiN}_x$  layer thickness increases in the multilayer film. At the beginning of the wear test, the contact between the two sliding surfaces is done through the asperities of the film and ball, which are removed under the shear force; then, the debris will form the initial transfer layer on the contact area. The excess debris will accumulate either in the front of the sliding ball or on both sides of the wear track. Some hard debris could be further incrustated on the surface of the film, resulting in the rise of the friction coefficient at this time. The  $\text{Ag-SiN}_x$  layer, where epitaxial growth is reduced, exhibits low hardness and, consequently, is easily removed under the shear force to form the transfer layer, resulting in an increase in the maximum frictional force in the running-in stage. Therefore, the maximum friction coefficient in the running-in stage increases gradually with the increase of the  $\text{Ag-SiN}_x$  layer thickness. The decrease in the friction coefficient after the running-in stage might be attributed to the formation of a lubricant transfer layer including the lubricant tribo-phases as well as the lubricant debris of Ag and  $\text{Mo}_2\text{N}$ . For all the films, after the running-in stage, the friction coefficient is stable throughout the rest of the test.

The average CoF values of the multilayered films, shown in Fig. 8(b), first remain stable close to  $\sim 0.50$  for the 2–6 nm

$\text{Ag-SiN}_x$  layer films and then decrease gradually from  $\sim 0.45$  to  $\sim 0.41$  for the 12 nm  $\text{Ag-SiN}_x$  layer film.

Figure 9 shows the wear track morphologies of the multilayer films after the wear test at RT. All the coated samples are not completely worn out, since the maximum depth of the wear track, regardless of the  $\text{Ag-SiN}_x$  layer thickness, is less than  $2 \mu\text{m}$ . The obvious scratches on the wear track surface of all the multilayered films in Fig. 9 also confirm the effect of the asperities on the formation of hard particles that are transferred to the third body formed during the running-in stage of the friction curves, as shown in Fig. 8(a). Moreover, similar detailed information of the wear track for each sample from four different regions, including the depth, width, and accumulation of the transfer layers, can be observed in Fig. 9, indicating a continuous stable contact of the counterpart with the sample during the wear test. Figures 9(a) and 9(b) show a narrow wear track depth after the tribotest of the multilayer film at the 2 nm  $\text{Ag-SiN}_x$  layer, with depths and widths of  $\sim 1.1$  and  $\sim 300 \mu\text{m}$ , respectively. The accumulation of worn-out material appears on both (A and C regions) or single (B and D regions) sides of the wear track, with a darker color. The tribo-chemical actions with the counterpart and the sample induce the formation of tribo-phases during the slide, and consequently, the tribolayers accumulate on the side of the wear track. A wider wear track with a width of  $\sim 500 \mu\text{m}$  is detected as the  $\text{Ag-SiN}_x$  layer thickness increases to 6 nm (Figs. 9(c) and 9(d)); however, the depth remains at a similar value of  $\sim 1.1 \mu\text{m}$ . The slight decrease in hardness corresponds to a low load-bearing capacity of the film and consequently increases the contact area with the counterpart under the same load. The increase in the  $\text{Ag-SiN}_x$  layer thickness also enlarges the dark region areas on either the center (Fig. 9(a)) or the sides (Figs. 9(b)–9(d)) of the wear track, where the transfer layers accumulate on the surface, as shown in Fig. 9(c). The number of scratches on the wear track surface also increases compared with that observed in Fig. 9(a). The brittle but hard  $\text{SiN}_x$ -based debris from the  $\text{Ag-SiN}_x$  layer moving along with its counterpart during the wear test might be responsible for this. Increasing the  $\text{Ag-SiN}_x$  layer thickness to 12 nm further enlarges the dark area, covering almost the entire surface of the wear track, as shown in Fig. 9(e). Although deep scratches could be detected on the track surface, the number of scratches obviously decreased. A decrease in the hardness of a sample slightly increases the width of the wear track to  $\sim 550 \mu\text{m}$ . However, a shallower wear track depth appears during this period, with a maximum value of  $\sim 1.0 \mu\text{m}$ , which could result from the adhesion of transfer layers. This also leads to the lowest value of the wear rate for all multilayered samples.

Figure 10 depicts the influence of the  $\text{Ag-SiN}_x$  layer thickness

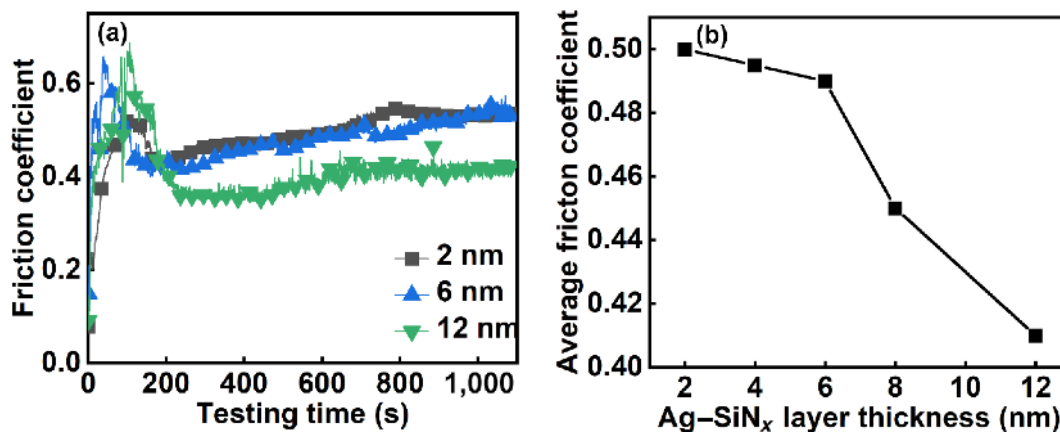


Fig. 8 (a) RT representative friction curves and (b) average friction coefficient of multilayered  $\text{Mo}_2\text{N-SiN}_x/\text{Ag-SiN}_x$  film as a function of  $\text{SiN}_x$  layer thickness.

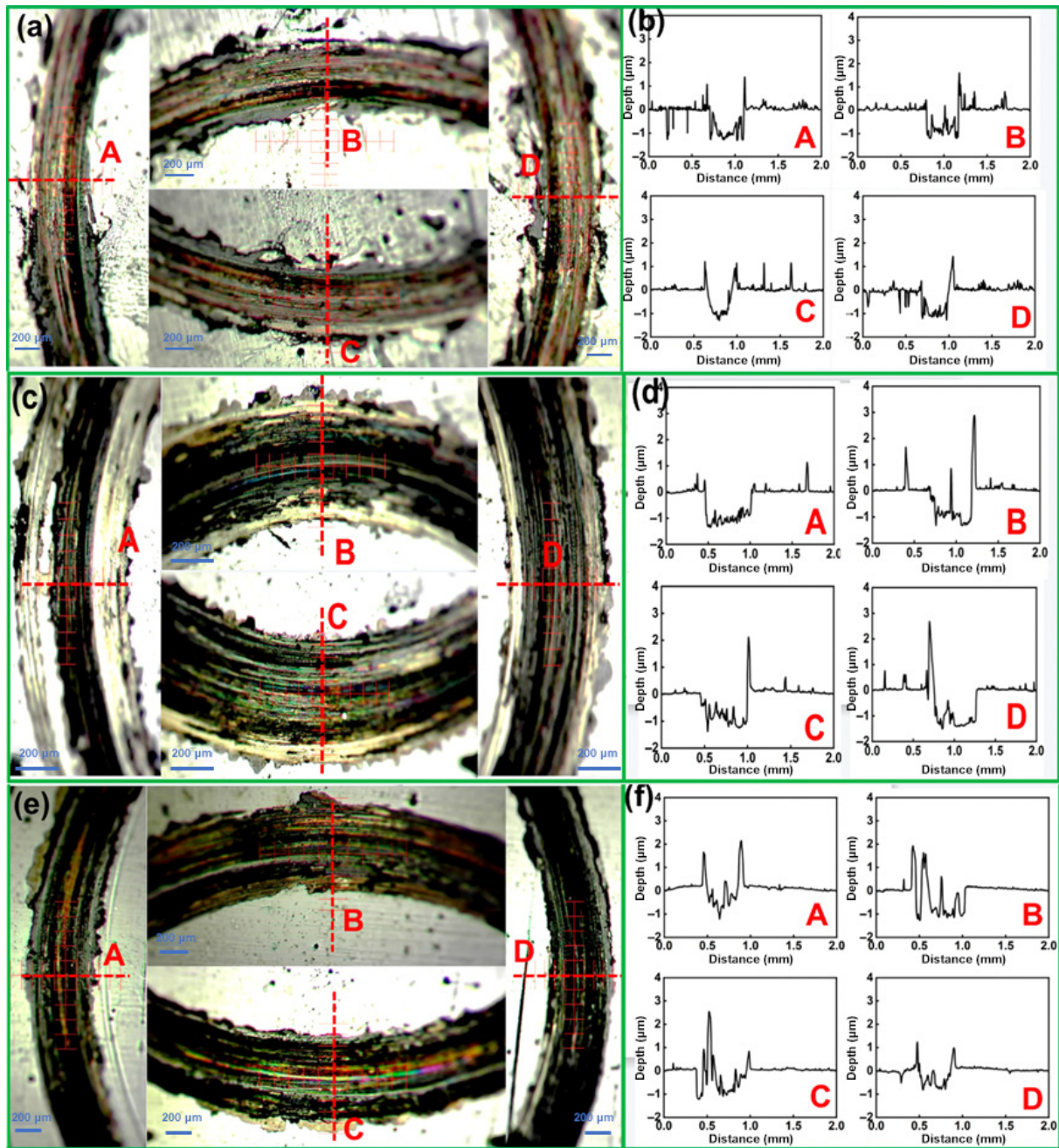


Fig. 9 Optical morphologies of quartered regions of circular wear track, and its corresponding 2D curves after wear test at room temperature: (a, b) 2 nm, (c, d) 6 nm, and (e, f) 12 nm.

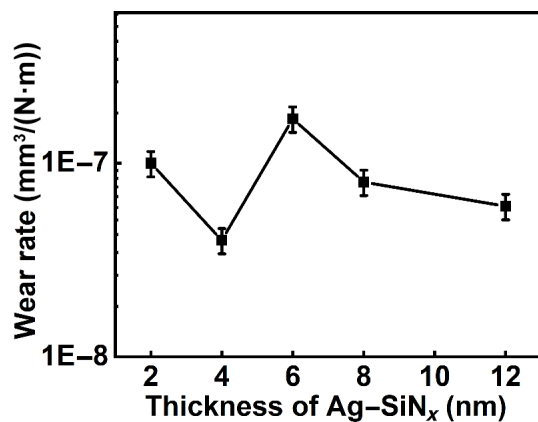


Fig. 10 RT wear rate of multilayered Mo<sub>2</sub>N-SiN<sub>x</sub>/Ag-SiN<sub>x</sub> film as a function of SiN<sub>x</sub> layer thickness

on the RT WR against the counterpart of Al<sub>2</sub>O<sub>3</sub>. The WR of the multilayer film at the 2 nm Ag-SiN<sub>x</sub> layer is  $\sim 1.0 \times 10^{-7} \text{ mm}^3/(\text{N}\cdot\text{mm})$  and drops significantly to  $\sim 4.1 \times 10^{-8} \text{ mm}^3/(\text{N}\cdot\text{mm})$  when the Ag-SiN<sub>x</sub> layer increases to 4 nm but increases again to  $\sim 1.7 \times 10^{-7} \text{ mm}^3/(\text{N}\cdot\text{mm})$  for the film at the 6 nm Ag-SiN<sub>x</sub> layer. Then, the WR gradually decreases with a further increase of the Ag-SiN<sub>x</sub> layer thickness from 8 to 12 nm. The lowest value of WR is registered for the film at the 4 nm Ag-SiN<sub>x</sub> layer, which has the highest hardness, and the film at the 12 nm Ag-SiN<sub>x</sub> layer has the second lowest value of WR; however, in this case, the factor that contributes to this result is the highest amount of soft phase that results in a lower friction.

Figure 11 shows the Raman spectra after the RT wear tests as well as the Raman spectrum from outside of the wear track of the film at the 2 nm Ag-SiN<sub>x</sub> layer, corresponding to the as-deposited film. The as-deposited film exhibits no obvious Raman peaks that

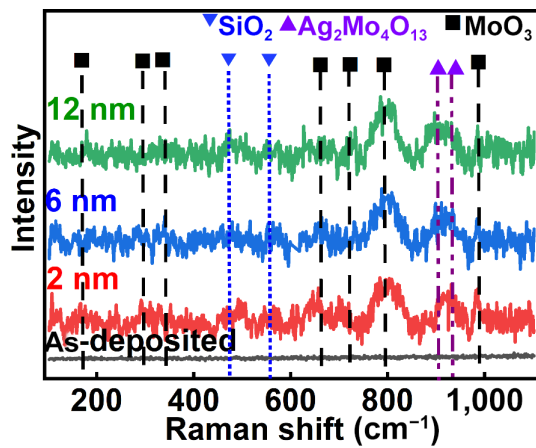
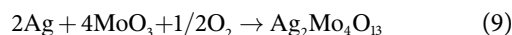


Fig. 11 Raman spectra from as-deposited and wear track of  $\text{Mo}_2\text{N-SiN}_x/\text{Ag-SiN}_x$  multilayer film after wear test at RT.

could be associated with the formation of any compound. However, on the wear track for all the films, the Raman peaks corresponding to  $\text{Ag}_2\text{Mo}_4\text{O}_{13}$  and  $\text{MoO}_3$  can be identified in all the spectra. This finding indicates that the transfer layer on the wear track surface might have similar tribo-phase components for all of the tested films. Double layers of distorted edge-sharing  $\text{MoO}_6$  octahedra parallel to the (010) planes are in the  $\text{MoO}_3$  phase, with only van der Waals forces holding the successive layers. Therefore, a low shear strength occurs during the wear test [57]. Layered  $\text{MoO}_3$  has been widely reported as a classic self-lubricant tribo-phase, which is easily formed on the sliding surfaces by complex tribo-chemical actions during wear tests either at RT or elevated temperatures, enhancing the anti-frictional performance [39, 58]. The appearance of  $\text{Ag}_2\text{Mo}_4\text{O}_{13}$  tribo-phase, rather than  $\text{Ag}_2\text{MoO}_4$  or  $\text{Ag}_2\text{Mo}_2\text{O}_7$ , could be expected given the high mole percentage of Mo in the films, based on the  $\text{MoO}_3\text{-Ag/Ag}_2\text{O}$  phase diagram. Wenda [59] reported an interesting experimental result of easy formation of  $\text{Ag}_2\text{Mo}_4\text{O}_{13}$  at RT without any heating through the investigation on the powder mixture of  $\text{MoO}_3$  and Ag or  $\text{Ag}_2\text{O}$ , which was maintained for a long period of time. Thus, it is reasonable to form the tribo-phase of  $\text{Ag}_2\text{Mo}_4\text{O}_{13}$  tribo-chemical processes at RT wear tests after the induction of  $\text{MoO}_3$  tribo-phase formation, according to Reaction (9) [59]:



or (10):



The double metal oxide tribo-phase also exhibits excellent self-lubricant characteristics during the wear test [60]. Moreover, vestiges of Raman peaks at  $\sim 460$  and  $\sim 520$   $\text{cm}^{-1}$ , corresponding to  $\text{SiO}_2$  [61], could be detected. The hard phase of  $\text{SiO}_2$  phase in the transfer layer is responsible for the appearance of scratches on the wear track surface.

Based on the above, the tribological properties of the multilayer films at RT are significantly influenced by the Ag-SiN<sub>x</sub> layer thickness: The lowest CoF can be obtained for the film with a 12 nm Ag-SiN<sub>x</sub> layer, which has satisfactory wear resistance performance; however, the lowest WR is detected for the film with a Ag-SiN<sub>x</sub> layer of 4 nm due to its excellent mechanical properties.

Several factors influence the anti-friction characteristics:

(i) Transfer layers. Lubricant tribo-phases, including

$\text{Ag}_2\text{Mo}_4\text{O}_{13}$  and  $\text{MoO}_3$ , co-exist in the transfer layers to lubricate the wear track and consequently drop the CoF.

(ii) Contact area. A large contact area induced by the low hardness of the film with thickness of Ag-SiN<sub>x</sub> layer > 6 nm may result in relatively high friction during the wear test. However, the enlarging transfer layer area is also detected for the film with a large contact area, thereby enhancing the anti-friction properties to drop the CoF.

(iii) Ag-SiN<sub>x</sub> layer thickness. The Ag-SiN<sub>x</sub> monolayer film has a relatively low CoF below 0.40 under the same testing conditions [12] because of the excellent lubricant nature of pure Ag phase, as well as the lubricant synergism between SiN<sub>x</sub> and Ag. The thick Ag-SiN<sub>x</sub> layers inserted into the  $\text{Mo}_2\text{N-SiN}_x$  matrix enhance the anti-friction properties.

A balance among the contact area, Ag-SiN<sub>x</sub> layer thickness, and transfer layer could be achieved, and then, the CoF gradually decreased for the film with the thickness of Ag-SiN<sub>x</sub> layer > 6 nm.

For the WR of the film, the influent factors are as follows:

(i) The mechanical properties of the films can significantly influence their wear resistance properties at RT. A higher mechanical strength is similar to a higher load-bearing capacity [62, 63], which ultimately leads to a smaller contact area with the counterpart. In addition, the toughness could be enhanced by the epitaxy architecture [64], improving the wear resistance property. This could be considered a main factor resulting in the low WR for the film with a 4 nm Ag-SiN<sub>x</sub> layer.

(ii) Another important issue that could also be taken into consideration to investigate the WR is the anti-friction properties. Although the widest wear track could be detected for the film at the 12 nm Ag-SiN<sub>x</sub> layer, owing to its lower hardness, its lowest CoF, softens the contact between the film and its counterpart, and gives rise to a shallower wear track, resulting in a low WR.

Figure 12 illustrates the friction curves of the  $\text{Mo}_2\text{N-SiN}_x/\text{Ag-SiN}_x$  multilayer films with 2, 6, and 12 nm Ag-SiN<sub>x</sub> layers at 600 °C. The friction coefficient of the film, regardless of the Ag-SiN<sub>x</sub> layer thickness, can be divided into three stages: (i) The first stage is the running-in, which occurs at the beginning of the wear test, where the friction coefficient strongly fluctuates, with an increase in the beginning of the test for short time of less than 80 s. (ii) Then, the friction coefficient gradually decreases with time for all the samples. The increase of the Ag-SiN<sub>x</sub> layer thickness induces a decrease in the friction coefficient throughout the test in relation to that of the mother films. Moreover, the time to reach the low stable value of the friction coefficient decreases from  $\sim 1,000$  s for the 2 nm Ag-SiN<sub>x</sub> layer down to  $\sim 750$  s for the 12 nm Ag-SiN<sub>x</sub> layer. (iii) In the last stage, the friction coefficient

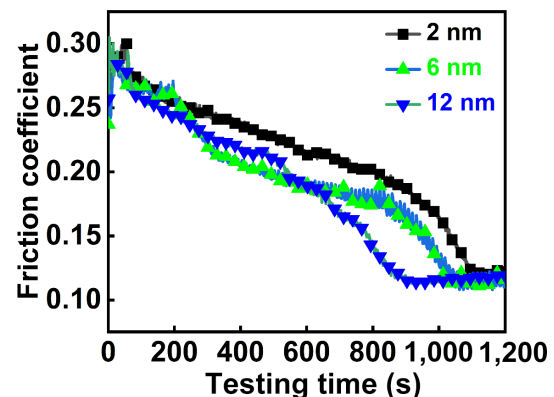
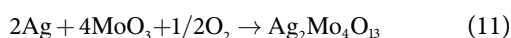


Fig. 12 Friction coefficient vs. testing time of  $\text{Mo}_2\text{N-SiN}_x/\text{Ag-SiN}_x$  multilayer film at 600 °C.

of the film is independent of the Ag-SiN<sub>x</sub> layer thickness, with a remarkable value of ~0.12 at the end of the test.

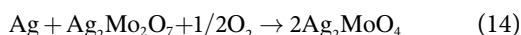
The Raman spectra of the wear track surface after the 700 s and 1,200 s wear test durations are shown in Fig. 13 to investigate the evolution of the tribo-phases with the testing time at 600 °C. The Raman peaks attributed to MoO<sub>3</sub> [65] and Ag<sub>2</sub>Mo<sub>4</sub>O<sub>13</sub> [66] can be detected in the wear tracks of both samples after 700 s, as shown in Fig. 13(a). However, a new tribo-phase of Ag<sub>2</sub>MoO<sub>4</sub> [67] is detected in the Raman spectra of the wear track after 1,200 s, with the disappearance of Ag<sub>2</sub>Mo<sub>4</sub>O<sub>13</sub> phase. In addition, the definition and intensity of Ag<sub>2</sub>MoO<sub>4</sub> peaks increase with the increase of Ag-SiN<sub>x</sub> layer thickness. This suggests that more Ag<sub>2</sub>MoO<sub>4</sub> tribo-phases form on the wear track to influence the tribological properties at 600 °C for the multilayer films with thicker Ag-SiN<sub>x</sub> layers. The evolution of Ag-based binary transition metal oxide tribo-phases can be understood from the Raman results. The Ag<sub>2</sub>Mo<sub>4</sub>O<sub>13</sub> phase can be easily formed after the development of MoO<sub>3</sub> in the wear test at 600 °C by the tribo-chemical action according to Reaction (11) [59]:



or (12):



The thickness of the transfer layer, induced by tribochemical and/or physical action under the counterpart, gradually increases with increasing test time at 600 °C, and then, the initially relatively fast diffusion is avoided, resulting in the evolution of Ag<sub>2</sub>Mo<sub>4</sub>O<sub>13</sub> into Ag<sub>2</sub>MoO<sub>4</sub> [68] via Reactions (13) and (14) [59]:



Layered Ag<sub>2</sub>MoO<sub>4</sub> has been reported as one of the most common lubricant materials for applications at elevated temperatures [69] because of its weak Ag-O bonds linking [MoO<sub>4</sub>] tetrahedra to [AgO<sub>6</sub>] octahedra [70]. Therefore, the evolution of the tribo-phase of Ag-based binary transition metal oxide from Ag<sub>2</sub>Mo<sub>4</sub>O<sub>13</sub> to Ag<sub>2</sub>MoO<sub>4</sub> with the increase of the test time during the wear test at 600 °C could be considered the main factor responsible for the evolution of friction in the second and third stages for multilayer films at 600 °C, as follows.

(i) The lubricant tribo-phases of MoO<sub>3</sub> and Ag<sub>2</sub>Mo<sub>4</sub>O<sub>13</sub> can form on the wear track surface, governing lubrication during the

wear test, with their contents increasing with continuous contact with their counterparts. This results in a gradual decrease in the friction coefficient with increasing test duration after the running-in stage.

(ii) The evolution of the tribo-phase from Ag<sub>2</sub>Mo<sub>4</sub>O<sub>13</sub> to Ag<sub>2</sub>MoO<sub>4</sub> also enhances the anti-friction performance, resulting in a decrease in the friction coefficient as a function of testing time.

(iii) The total phase transformation to Ag<sub>2</sub>MoO<sub>4</sub> leads to the appearance of the third stage of the curve, with a friction coefficient value of ~0.12.

(iv) The low melting point of Ag<sub>2</sub>MoO<sub>4</sub> at ~570 °C could induce solid-liquid lubrication to further enhance the anti-friction properties, thereby contributing to the extremely low coefficient of ~0.12 in the third stage of the friction curve.

Figure 14 illustrates the optical wear track images and their corresponding 2D morphologies of the multilayered films after the wear test at 600 °C. Although the wear tracks of all the films, regardless of the Ag-SiN<sub>x</sub> layer thickness, can be detected, their depth is too shallow to calculate the WR. In addition, the roughness of the area outside the wear track increases gradually with the increase of Ag-SiN<sub>x</sub> layer thickness. Despite the multilayer configuration, the diffusion of Ag at 600 °C may occur despite the excellent anti-diffusion capacity of amorphous SiN<sub>x</sub>, as proven in our previous work on Ag-SiN<sub>x</sub> monolayer films [12].

The pretended wear resistance, at 600 °C, is achieved by the interlocked multilayered architecture due to the following reasons:

(i) The excellent anti-friction properties, especially the solid-liquid lubrication induced by the low melting point of Ag<sub>2</sub>MoO<sub>4</sub> tribo-phase, could soften the interaction with the counterpart, and hence, the extremely low friction coefficient contributes to the enhancement of the wear resistance.

(ii) The diffusion of Ag in SiN<sub>x</sub> matrix during the wear test toward the surface of the film compensates for the wear under the counterpart during the wear test.

(iii) The wear resistance properties could benefit from the volume expansion induced by the evolution of the tribo-phase from Ag<sub>2</sub>Mo<sub>2</sub>O<sub>7</sub> to Ag<sub>2</sub>MoO<sub>4</sub> [71].

(iv) The interlocked structure of the multilayered film effectively prevents interlayer delamination under shear forces during sliding contact because of the difference in the physical/chemical characteristics of each layer at elevated temperatures.

## 4 Conclusions

A series of nacre-like interlocked multilayered films with

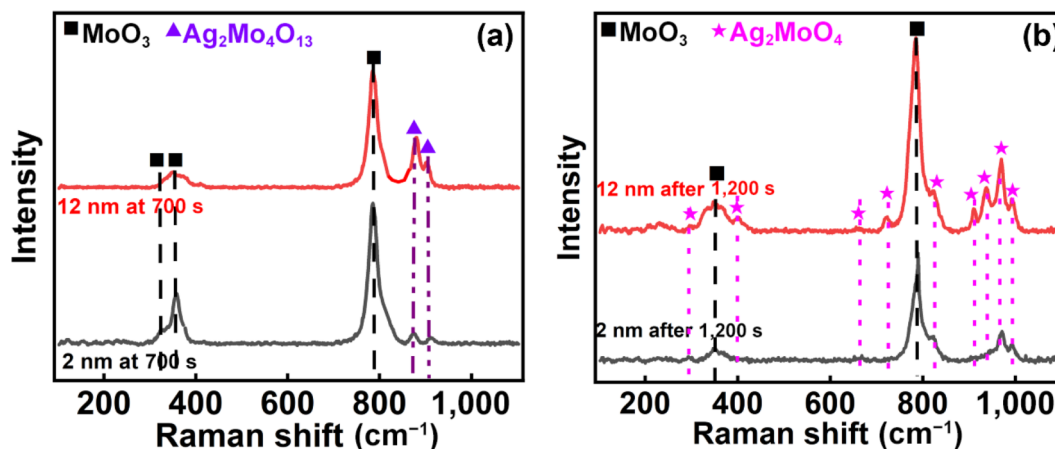
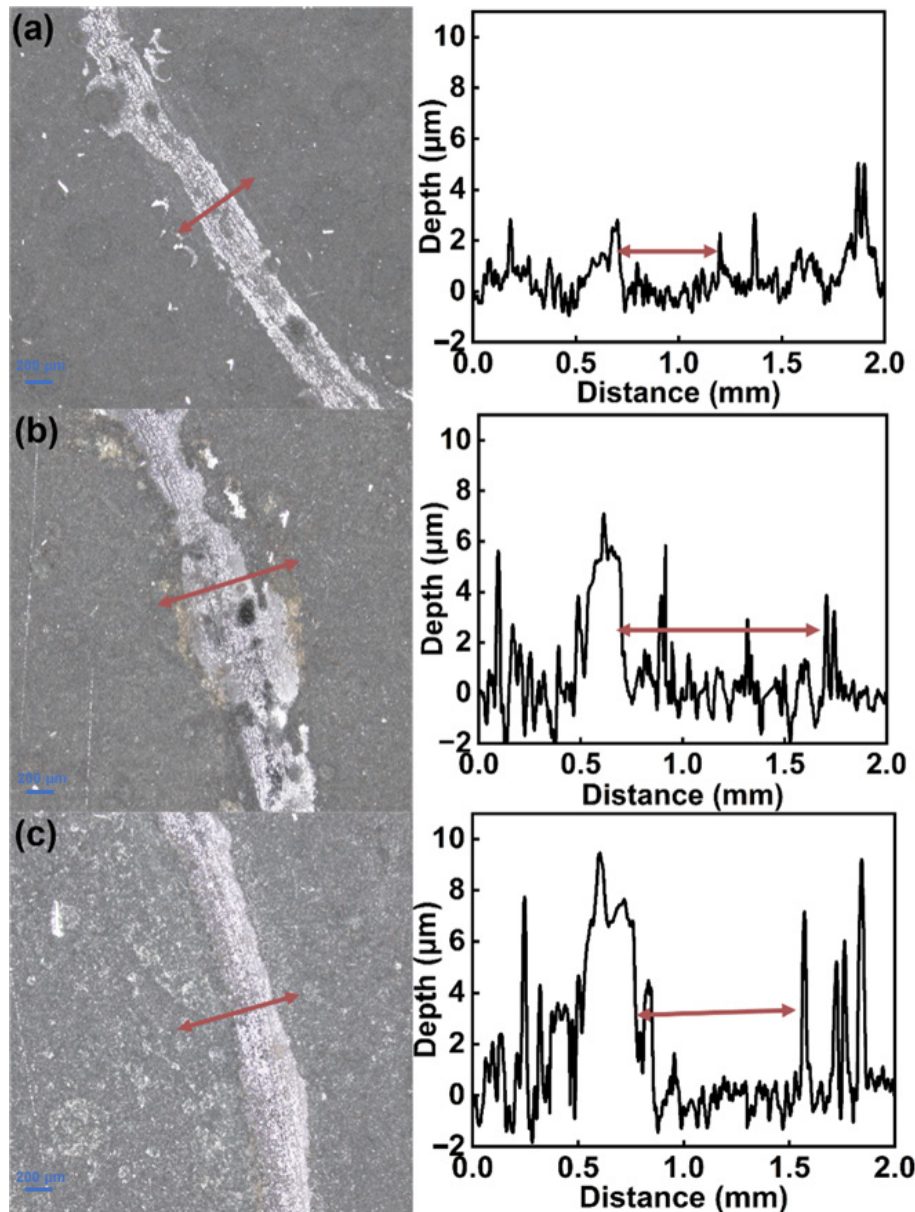


Fig. 13 Raman spectra from wear track of Mo<sub>2</sub>N-SiN<sub>x</sub>/Ag-SiN<sub>x</sub> multilayer films with 2 and 12 nm Ag-SiN<sub>x</sub> layer after (a) 700 s and (b) 1,200 s wear test at 600 °C.



**Fig. 14** Optical images of wear track surfaces and corresponding 2D wear track profiles of  $\text{Mo}_2\text{N-SiN}_x/\text{Ag-SiN}_x$  multilayer films with (a) 2 nm, (b) 6 nm, and (c) 12 nm Ag-SiN<sub>x</sub> layer after wear test at 600 °C.

alternating  $\text{Mo}_2\text{N-SiN}_x$  and Ag-SiN<sub>x</sub> nanolayers were designed and deposited using RF magnetron sputtering for a wide range of temperatures in key applications. For this purpose, several requirements need to be met: (i) the adequate formation of lubricant tribo-layers to ensure self-lubricant properties at RT and elevated temperatures by a tribological synergism between  $\text{Mo}_2\text{N}$  and Ag; (ii) the prevention of excessive diffusion of the lubricant agents toward the surface to achieve long-term lubrication by the introduction of a SiN<sub>x</sub> phase to form an interlocked structure; (iii) the appropriate blocking of the degradation of the mechanical properties to enhance the wear resistance by the coherent strengthening of the Ag-SiN<sub>x</sub> layer below 6 nm. The influence of the Ag-SiN<sub>x</sub> nanolayer thickness on the microstructure and mechanical and tribological properties of the multilayered films was investigated, and the main conclusions can be drawn as follows:

(1) In the zone without the coherency characteristic, a dual phase of fcc- $\text{Mo}_2\text{N}$  and SiN<sub>x</sub> co-existed in the  $\text{Mo}_2\text{N-SiN}_x$  layers, with amorphous SiN<sub>x</sub> encapsulating  $\text{Mo}_2\text{N}$  nano-crystalline phase;

the Ag-SiN<sub>x</sub> layers exhibited a dual phase of fcc-Ag and amorphous SiN<sub>x</sub>, with the Ag nanoparticles embedded into an amorphous matrix. However, the thickness of the Ag-SiN<sub>x</sub> layer below 6 nm could induce the coherency structure in some areas where Ag or Ag-SiN<sub>x</sub> could epitaxially grow over the  $\text{Mo}_2\text{N}$  template.

(2) Inserting the Ag-SiN<sub>x</sub> layer ( $\leq 6$  nm) into the  $\text{Mo}_2\text{N-SiN}_x$  matrix induced a remarkable increase in hardness, which was attributed mainly to the coherent strengthening induced by the epitaxial growth of the Ag-SiN<sub>x</sub> layers over the  $\text{Mo}_2\text{N}$  template layers. The coherency structure also led to an increase in the elastic modulus. Both the hardness and elastic modulus of the multilayered film with  $> 6$  nm Ag-SiN<sub>x</sub> layer followed the rule of mixture, with values close to the weighted average of those of the individual layers.

(3) The RT average friction coefficient of the multilayered film decreased gradually from  $\sim 0.50$  for the 2–6 nm Ag-SiN<sub>x</sub> layer to  $\sim 0.41$  for the 12 nm Ag-SiN<sub>x</sub> layer; the anti-friction performance of the Ag-SiN<sub>x</sub> layer and the lubricant tribo-phases of  $\text{Ag}_2\text{Mo}_4\text{O}_{13}$ ,

and MoO<sub>3</sub> increased the formation of lubricious materials during the wear test. Excellent RT wear resistance was detected for all multilayered films, with wear rates ranging from  $4 \times 10^{-8}$  to  $1 \times 10^{-7}$  mm<sup>3</sup>/(N·mm). The lowest values of the friction and wear coefficients were found for the films with 4 and 12 nm Ag–SiN<sub>x</sub> layers.

(4) At 600 °C, in all multilayer films, the friction coefficient gradually decreased with testing time, reaching a value of ~0.12 at the end of the test. This behavior was attributed to the evolution of the formation of the lubricant tribo-phases. The diffusion of Ag toward the surface, as well as the tribo-phase transformation from Ag<sub>2</sub>Mo<sub>4</sub>O<sub>13</sub> to Ag<sub>2</sub>MoO<sub>4</sub>, contributed to the excellent wear resistance properties, with a very shallow wear track, not allowing to calculate the wear rate.

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### Declaration of competing interest

The authors have no competing interests to declare that are relevant to the content of this article.

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